

**Notice of References Cited**

Application/Control No.

10/538,023

Applicant(s)/Patent Under

Reexamination

IWAKUMA ET AL.

Examiner

MICHAEL E. NELSON

Art Unit

1794

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-6,351,067 B1	02-2002	Lee et al.	313/504
*	B US-2002/0081456 A1	06-2002	Hamada, Yuji	428/690
*	C US-2003/0205696 A1	11-2003	Thoms et al.	252/301.16
*	D US-2007/0054151 A1	03-2007	Iwakuma et al.	428/690
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

**FOREIGN PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N	EP 517542	12-1992	Europe	Noguchi et al.	
O					
P					
Q					
R					
S					
T					

**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	
V	
W	
X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.